

2832 HV

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Atty. Docket

BART BUIJSSE

PHQ 99015

Serial No. 09/741,672

Group Art Unit: 2882

Filed: December 19, 2000

Examiner: Jurie Yun

X-RAY MICROSCOPE HAVING AN X-RAY SOURCE FOR SOFT X-RAYS

Commissioner for Patents Alexandria, VA 22313-1450

AMENDMENT

Sir:

In response to the Official Office Action dated 14 May 2004, please amend the above-identified application as follows:

IN THE CLAIMS

- 1. (currently amended) An X-ray microscope which includes a device for generating X-rays, which device is provided with:
 - means for producing a fluid jet—(2),
 - means for forming a focused radiation beam whose focus is situated on the fluid jet,

characterized in that

<u>said</u> the focused radiation beam consists of comprising a beam (6) of electrically charged particles.

2. (currently amended) An X-ray microscope as claimed in Claim 1, wherein the beam of electrically charged particles comprises is formed by an electron beam.

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